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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Application Serial No. 09/360,292
Filing Date July 22, 1999
Inventor Sujit Sharan et al.
Assignee Micron Technology, Inc.
Group Art Unit 1746
Examiner Ahmed, Shamim
Attorney's Docket No. MI22-1106
Title: Plasma Etching Process

Assistant Commissioner of Patents

Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY

Please recognize Jennifer J. Taylor, Ph.D. (Reg. No. 48,711), Frederick M. Fliegel, Ph.D. (Reg. No. 36,138), D. Brent Kenady (Reg. No. 40,045), and James E. Lake (Reg. No. 44,854), whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as an associate attorney or agent in the above-entitled application.

Date: 4-15-02
Mark S. Matkin
Reg. No. 32,268**OFFICIAL**
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